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APPLICANTS

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** CONTINUING DATA ***** None AICs

** FOREIGN APPLICATIONS ***** None AICs

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 06/03/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged Examiner's Signature: <i>Ashwinder Sandhu</i> Initials: <i>AS</i>	STATE OR COUNTRY CHINA	SHEETS DRAWING 13	TOTAL CLAIMS 165	INDEPENDENT CLAIMS 7
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TITLE
 Methods of depositing silicon dioxide comprising layers in the fabrication of integrated circuitry, methods of forming trench isolation, and methods of forming arrays of memory cells

FILING FEE RECEIVED 3854	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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